

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 146712002800

Application Number to be assigned

Applicant

Qixu CHEN et al.

Filing Date December 20, 2001

Group Art Unit to be assigned

Hand-filed Date December 20, 2001

10/022728
10/02/01

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
<i>7/10/01</i>	1.	02/06/2001	6,183,832	Margulies et al.			
	2.	12/05/2000	6,156,404	Ross et al.			
<i>4</i>	3.	10/17/2000	6,132,892	Yoshikawa et al.			
<i>4</i>	4.	12/28/1999	6,077,924	Lal et al.			
<i>4</i>	5.	03/03/1998	5,723,198	Hosoe et al.			
<i>7</i>	6.	03/21/1995	5,399,386	Jahnes et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
	7.						

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
	8.	

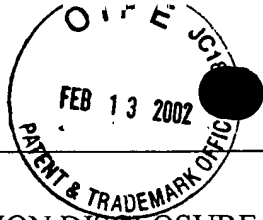
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Examiner Initials	Ref. No.	Title
<i>YH</i>	1	Li-Lien Lee, et al., "NiAl Underlayers for CoCrTa Magnetic Thin Films," <i>IEEE Transactions on Magnetics</i> , Vol. 30, No. 6, 11/94, pp. 3951-3953
<i>Y</i>	2	Li-Lien Lee, et al., "Seed Layer Induced (002) Crystallographic Texture in NiAl Underlayers," <i>Journal of Applied Physics</i> , Vol. 79, No. 8, 4/15/96, pp. 4902-4904
<i>Y</i>	3	Li-Lien Lee, et al., "FeAl Underlayers for CoCrPt Thin Film Longitudinal Media," <i>Journal of Applied Physics</i> , Vol. 81, No. 8, 4/15/97, pp. 4366-4368

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